

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

December 22, 2025

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG758580558

LABORATORY GROWN DIAMOND

OVAL BRILLIANT

8.26 X 5.73 X 3.55 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

1.06 CARAT

E

VS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

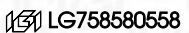
EXCELLENT

EXCELLENT

NONE

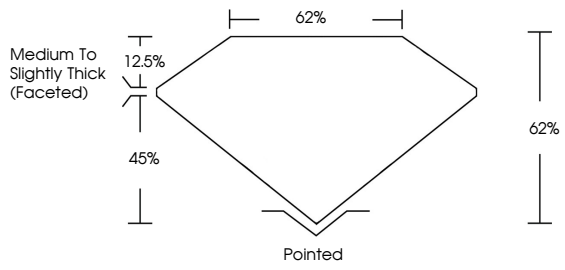
Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

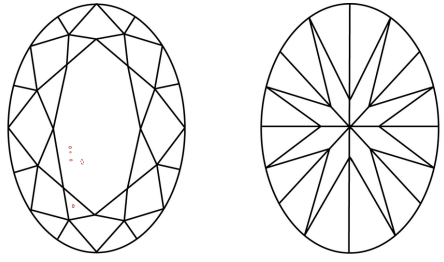


IGI LG758580558

PROPORTIONS



CLARITY CHARACTERISTICS





KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

CLARITY


D	E	F	G	H	I	J	Faint	Very Light	Light
FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³				
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included				



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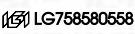
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IGI

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OVAL BRILLIANT

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Color Grade

Clarity Grade

Depth

Table

Girdle

Medium to Slightly Thick (Faceted)

Pointed

Polish

Symmetry

Fluorescence

Inscription(s)

1.06 CARAT

E

VS 1

62%

62%

Medium to Slightly Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

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